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Dated: February 18, 2005

Signature:

(Marco Jimenez)



Docket No.: 514802002600

Client reference: AD-0371US

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Mitsuyuki ASAKI et al.

Confirmation No.: 4476

Application No.: 10/664,440

Examiner: Johnnie L. Smith

Filed: September 18, 2003

Art Unit: 2881

For: PATTERN WIDTH MEASURING
APPARATUS, PATTERN WIDTH
MEASURING METHOD, AND ELECTRON
BEAM EXPOSURE APPARATUS

AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated November 18, 2004, for which a response is due on February 18, 2005, please amend the above-identified U.S. patent application as follows: